

receipt

PATENT 29936/39485

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

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Application of: Kwan Yong Lim et al.

Serial No.: 10/615,478

Filed: July 8, 2003

For: Method of Forming Gate in

Semiconductor Device

Group Art Unit: 2812

Examiner: To be assigned

I hereby certify that this paper and the documents referred to as enclosed therewith are being deposited with the United States Postal Service as first class mail, postage prepaid, on October 17, 2003, in an envelope addressed to Commissioner for Patents, P.O. Box 1450 Alexandria, Vinginia 22313-1450

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torney for Applicants

REQUEST FOR CORRECTED FILING RECEIPT

Commissioner for Patents P.O. Box 1450 Alexandria, Virginia 22313-1450

Sir:

Applicants request the issuance of a corrected filing receipt. A copy of the official filing receipt issued by the U.S. Patent and Trademark Office is enclosed with the following corrections noted in red: the city of residence for the first and second inventors should read "Kyungki-Do" not "Suwon-Shi" and "Euiwang-Shi." Accordingly, applicants respectfully request the issuance of a corrected filing receipt in connection with this application.

Respectfully submitted,

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October 17, 2003

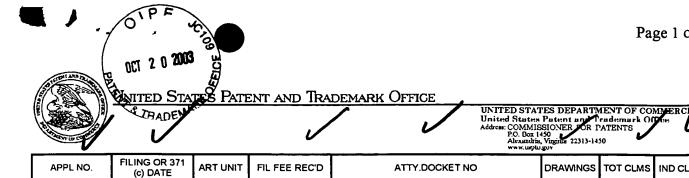
By:

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IND CLMS

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07/08/2003

RECEIVED FILING RECEIPT

29936/39485

CONFIRMATION NO. 9262

TOT CLMS

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DRAWINGS

OCT 1 4 2003

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Kyungki-do

MARSHALL GERSTEIN

Date Mailed: 10/08/2003

Receipt is acknowledged of this regular Patent Application. It will be considered in its order and you will be notified as to the results of the examination. Be sure to provide the U.S. APPLICATION NUMBER, FILING DATE, NAME OF APPLICANT, and TITLE OF INVENTION when inquiring about this application. Fees transmitted by check or draft are subject to collection. Please verify the accuracy of the data presented on this receipt. If an error is noted on this Filing Receipt, please write to the Office of Initial Patent Examination's Filing Receipt Corrections, facsimile number 703-746-9195. Please provide a copy of this Filing Receipt with the changes noted thereon. If you received a "Notice to File Missing Parts" for this application, please submit any corrections to this Filing Receipt with your reply to the Notice. When the USPTO processes the reply to the Notice, the USPTO will generate another Filing Receipt incorporating the requested corrections (if appropriate).

Applicant(s)

10/615,478

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Domestic Priority data as claimed by applicant

Foreign Applications

If Required, Foreign Filing License Granted: 10/07/2003

Projected Publication Date: 01/13/2005

Non-Publication Request: No

Early Publication Request: No

Title

Method of forming gate in semiconductor device

Preliminary Class